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October 2, 2003

**Mail Stop Application Number**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attorney Reference: OKI 384

**Re:** New Patent Application of: Junichi MIYANO, Kiyohiko TOSHIKAWA  
and Yoshikazu MOTOYAMA

**Title:** METHOD OF FABRICATING A PROTECTIVE FILM BY USE OF  
VACUUM ULTRAVIOLET RAYS

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (25 Pages)
- [x] 4 Sheets of Formal Drawings (Fig. 1 through Fig. 4)
- [x] Claim for priority (priority document to be submitted later).

In view of the above, it is requested that this application be accorded a filing date pursuant to 37 C.F.R. 1.53(b).

The right of priority is claimed under 35 USC §119 of Japanese Application No. 2002-289860, filed October 2, 2002

A Declaration signed by the inventor, and the filing fee will be submitted in due course.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)  
(Customer No. 23995)

October 2, 2003

Date

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